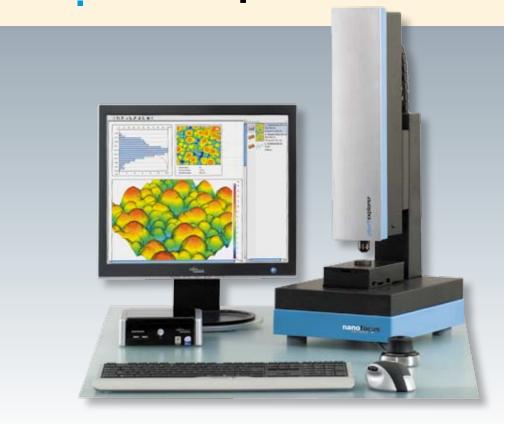


usurf explorer



The µsurf explorer compact optical 3D measuring instrument is a complete package for measuring and analyzing surfaces. µsurf explorer is based on the proven µsurf confocal technique. The cost-effective system is suitable both for use in the testing laboratory, as well as for the production environment.

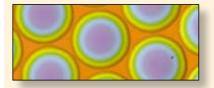
µsurf explorer can be used for DIN EN ISO compliant roughness determination, analyses of 3D structures,

layer thickness and measurement of geometry in the micrometer and nanometer range.

The technology is successfully deployed in numerous companies. These include renowned companies from the automotive industry, medical technology, microelectronics, the printing and paper industry, as well as a large number of research institutes.

- ← Robust and reliable
- Flexible all round measurement solution
- ← User-friendly concept
- ← Measurement in seconds
- ← High optical resolution
- ← Real 3D measurement data

MEMS/MOEMS



Automotive



Electronics



Medical technology



Robust and reliable

Measurement is effortless and reliable, even in harsh production environments. As standard IP 52 protection class and vibration absorbing feet are included. Environmental influences, such as vibrations, dust or splashed water do not affect the precision of the measurement results.

Low maintenance and durable components are used in µsurf explorer, for example a high power LED. This guarantees an instrument always ready for use and saves costs.



µsurf explorer in production

Flexible all round measurement solution

µsurf explorer is ideal for a broad spectrum of materials. From polymers to metals through to composite materials, all surfaces can be transformed into precise measurement data. Special algorithms, measurement modes and analysis programs open up an enormous bandwidth of measurement tasks.

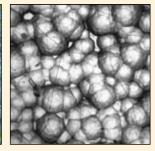
µsurf explorer is suitable both for automated quality assurance in production, as well as for versatile use in the research laboratory.

The stitching function is a standard and allows expanded measurement fields.

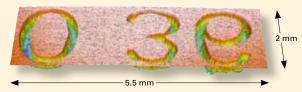
Rough paper surface

008

Steel roll (reflection image)



8x3 stitching of a laser mark



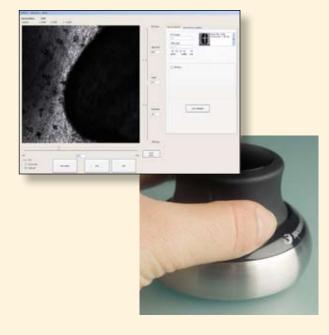
User-friendly concept

The basic concept of μ surf explorer is simple and intuitive operation of hardware and software. Even untrained operators can generate significant measurements after a brief induction period.

The one click function provides for measurements on the same type of sample or on series components. The measurement settings can be set once for the entire measurement series.

The user obtains additional support with the auto-adjustfunction. The measuring range and light intensity are automatically set by the system.

All measurement settings can be stored in measurement templates. Linking with individually configurable protocol templates makes evaluation easy, reliable and meaningful.



Measurement in seconds

No sample preparation is required for measurement with µsurf explorer. The object simply needs to be placed on the sample stage. Following selection of the measurement parameters, the measurement starts automatically. Useful measurement data are available after 5 to 10 seconds for further analysis.

With the µsoft analysis protocol templates you obtain full evaluation protocols within a few seconds.

Measurement time



Typical measurement system: >180 sec

High optical resolution

The nanometer precision resolution is based on innovative confocal Multi-Pinhole-Technology in combination with the piezo module. Even rough surfaces and structures with steep flank angles can be captured.

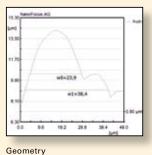
Even strongly reflecting or diffusely reflecting materials are captured error-free.

The objective lens used offers individual measurement field sizes between 1.6 x 1.6 mm and 260 x 260 μ m depending on the magnification with freely selectable vertical resolution.



Real 3D measurement data

Real 3D data are available after each measurement. Only these quantitative data allow an accurate evaluation of 3D parameters. Besides standardized surface and 3D parameters, µsurf analysis also offers numerous other functions, such as volume determination, calculation of isotropy or particle analysis. Of course, the software also includes all DIN EN ISO standardized 2D parameters and a wealth of international characteristic values







Azaal von insein 288
Durchschnittsvolumen der Insein 5,3 am
Durchschnittsvolumen der Insein 6,117 am
Durchschnittschie der Insein 7,17 am
Durchschnittschie der Insein 7,17 am
Durchschnittschie Verhalten 190e i Pläche
0,00432 junipund

Vmc = 2.21e-006 ml/m2

Volume

Particles



| Measuring nead | |
|--------------------------|---|
| Image acquisition module | Fast digital camera with progressive scan technology, up to 55 fps, 512x512 Pixel, 10 bit, firewire |
| Light source | High efficiency LED, (λ = 505 nm), MTBF: 50,000 h |

Scan modules

Manager band

| x,y-axis module MN 50 | Precision x,y-table, range: 50x50 mm, resolution: 0.3 μm | | |
|--------------------------|--|--|--|
| z-axis module MN 75 | Precision scanning module, range: 75 mm | | |
| z-axis module NV 250 | Fast precision scanning module (piezo), range: 250 μm, resolution: <10 nm | | |
| Peripherals & controller | Compact PC with Intel Core Duo processor, Windows XP Professional, 1 GB RAM, Firewire, DVD-Writer, ethernet, 19" TFT monitor, wireless keyboard and mouse, 3D hand navigator, emergency stop | | |
| Granite measuring stand | 440x260x320 mm (hxwxd) including vibration isolation rubber feet | | |

Software

| µsoft control | NanoFocus control and analysis software, profile and topography representation, roughness compliant with DIN EN ISO | |
|--------------------------------------|---|--|
| μsoft analysis (standard version) | Software to analyse 3D measurement data, layout function, templates for series measurement and analysis | |
| Stitch (Standard) | μsoft control plugin for extended measurement field | |

Optical modules

| | 1600 S | 800 L, S, XS | 320 L, S | 260 XS |
|-----------------------------------|-----------|--------------|----------|---------|
| Magnification | 10x | 20x | 50x | 60x |
| Measuring field (µm) | 1600×1600 | 800x800 | 320x320 | 260×260 |
| Numerical aperture | 0.3 | 0.4/0.45/0.6 | 0.5/0.8 | 0.9 |
| Working distance (mm) | 11.0 | 12.1/3.1/0.9 | 10.6/1.0 | 0.4 |
| Resolution in z-direction (nm) | 20 | 6/5/4 | 4/2 | 2 |
| Resolution in x, y-direction (μm) | 3.1 | 1.6 | 0.7 | 0.5 |

General

| Accessories (optional) | Vacuum plate, flatness/calibration standards, active absorbence plate, table, printer | | |
|------------------------|--|--|--|
| File formate | NMS, OMS, ACSII, SDF, TIF, BMP, MNT, SUR | | |
| File size | Single measurement approx. 0.8 MB | | |
| Typical measuring time | 5-10 seconds | | |
| Sample properties | Max. sample height: 70 mm, reflectivity: 1-100%, coated, non coated, reflective, diffuse | | |
| Vibration | Extra prevention for most applications not neccesary | | |
| Clean room class: | Capability class 6 (according to DIN EN ISO 14644) | | |
| Protection class: | IP 52 | | |
| Power supply | 100-240V, 50-60Hz, input: <45W | | |
| Total weight | 28 kg | | |
| Dimensions | 710x270x330 mm (hxwxd) | | |

Are you interested in other NanoFocus-Technology? Please call us +49 208 62 000 -0 or write an email to sales@nanofocus.de.

NanoFocus AG